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On April 4, 2003

TOWNSEND and TOWNSEND and CREW LLP

By: Heister Marina

**PATENT**  
Attorney Docket No.: A5604/T41700  
Client Ref. No.: 005604 USA/CPES/CORE/BG  
TTC No. 016301-041700US

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

TONY S. KAUSHAL

Application No.: 09/927,244

Filed: August 10, 2000

For: CORROSION RESISTANT  
COATING FOR SEMICONDUCTOR  
PROCESSING CHAMBER

Examiner: Thi D. Dang

Art Unit: 1763

RESPONSE TO OFFICE ACTION  
Mailed October 4, 2002

Assistant Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action mailed October 4, 2002, please enter the following amendments and remarks in the above-identified application as follows. A petition for a three-month extension of time to respond is being filed herewith.

**AMENDMENTS**

**In the Claims:**

Please cancel claims 8-14 without prejudice to filing of continuation application(s) drawn thereto.

Please amend claim 15 to read as follows.

15. (Amended) A method for treating a parent material for corrosion resistance to plasma comprising:

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